



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Mazumder et al.

Serial No.: 09/916,566

Group No.: 2125

Filed: July 27, 2001

Examiner: E. Frank

For: DIRECT METAL DEPOSITION APPARATUS UTILIZING RAPID-RESPONSE DIODE LASER SOURCE

AMENDMENT AND REPLY TO FINAL REJECTION

Mail Stop AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action mailed December 17, 2003, please amend the above-referenced application as follows: